Amendments to the Claims:

The following listing of claims will replace all prior versions, and listings, of claims in the application:

- (Currently Amended) Laser system having a repetition rate greater than 50
 kHz-according to the principle of the regenerative amplifier, comprising at least comprising:
 - an amplifying laser medium,
 - a laser resonator having at least one resonator mirror and at least one modulator, and
 - a pump source for pumping the laser medium,

wherein the laser resonator is designed to operate with a repetition rate of greater than 50kHz and has a pulse stretcher, inside a cavity of the resonator, as a specially designed component, the pulse stretcher having at least one of a structure- or material-related dispersive effect, the pulse stretcher having a minimum 3rd order dispersion with a maximum 2nd order dispersion.

- 2. (Previously Presented) Laser system according to Claim 1, wherein the pulse stretcher has a block of highly dispersive material.
- 3. (Previously Presented) Laser system according to Claim 2, wherein multiple reflections takes place within the block by reflections at interfaces.
- 4. (Previously Presented) Laser system according to Claim 1, wherein the pulse stretcher has a Gires-Tournois interferometer or a dispersive layer structure.
- 5. (Previously Presented) Laser system according to Claim 4, wherein the pulse stretcher has at least two reflecting surfaces, the surfaces being arranged in such a way that the surfaces are oriented
 - relative to one another and
 - at an opening angle

and the laser beam is reflected at least twice at at least one of the surfaces.

- 6. (Previously Presented) Laser system according to Claim 1, wherein the laser medium has an inversion life time greater than 1 ms.
- 7. (Previously Presented) Laser system according to Claim 1, wherein a femtosecond oscillator for inputting seed pulses, the femtosecond oscillator being formed and arranged in such a way that the seed pulses are femtosecond pulses or picosecond pulses on input into the laser resonator.
- 8. (Previously Presented) Laser system according to Claim 1, wherein an electrooptical switching element as modulator.
- 9. (Previously Presented) Laser system according to Claim 1, wherein a pulse compressor is outside the laser resonator.
- 10. (Previously Presented) Laser system according to Claim 9, wherein the pulse compressor has a dispersive grating having less than 1700 lines/mm.
- 11. (Previously Presented) Laser system according to Claim 1, wherein the pump source is a laser diode.
- 12. (Previously Presented) Laser system according to Claim 2, wherein the highly dispersive material is at least one of a SF57 glass, SF10 glass or BK7 glass.
- 13. (Previously Presented) Laser system according to Claim 5, wherein the opening angle is adjustable.
- 14. (Previously Presented) Laser system according to Claim 6, wherein the laser medium is a Yb:glass or a Yb:crystal.
- 15. (Previously Presented) Laser system according to Claim 9, wherein the pulse compressor has a dispersive grating having less than 1200 lines/mm.
- 16. (Previously Presented) Laser system according to Claim 4, wherein the dispersive layer structure is used as a folding mirror.

17. (Previously Presented) Laser system according to claim 9, wherein a relationship of the pulse compressor outside the laser resonator is according to a Treacy design.